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LIST OF DOCUMENTS CITED BY APPLICANT
(Use several sheets if necessary)

Applicant: Van De Ven et al.

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U.S. PATENT DOCUMENTS

[illegible]

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		Document Number	Date	Country	Class	Subclass	Translation Yes / No
<i>Kn</i>	4.	JP 61273590 ✓	12/10/86	Japan			Abstract
↑	5.	JP 541861 ✓	2/19/93	Japan			Abstract
	6.	JP 6326364 ✓	11/25/94	Japan			Abstract
	7.	JP 7110672 ✓	3/29/95	Japan			Abstract
	8.	JP 552882 ✓	7/13/93	Japan			Abstract
	9.	JP 252615 ✓	9/28/93	Japan			Abstract
	10.	JP 7283438	10/27/95	Japan			Abstract
	11.	JP 5190898	11/17/92	Japan			Abstract
↓	12.	JP 6187575	8/7/94	Japan			Abstract
✓	13.	JP 3065984	3/20/91	Japan			Abstract
<i>Kn</i>	14.	KR 9209891	11/5/92	Korea			Abstract

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

15.	Japanese Office Action (English Translation), corresponding Japanese Patent Application No. 524411/97, dated July 20, 2004.
16.	Notice to Submit a Response (English Translation), corresponding Korean Patent Application No. 1998-0704901, dated September 24, 2003.
17.	Notice to Submit a Response (English Translation), corresponding Korean Patent Application No. 1998-0704901, dated December 2, 2003.
18.	Notice to Submit a Response (English Translation), corresponding Korean Patent Application No. 2003-7015351, dated January 12, 2004.
19.	Notice to Submit a Response (English Translation), corresponding Korean Patent Application No. 2003-7015351, dated September 14, 2004.

Examiner:

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